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In re Application of:

E. Schieve

Serial No.: 09/755,516

Confirmation No.: 5078

Filed:

January 4, 2001

For:

Apparatus Having Platforms

Positioned For Precise

Centering of Semiconductor Wafers During Processing

Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Group Art Unit: 1763

Examiner:

K. Moore

CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on , 2002 with the United States Postal Service as First Class Mail/ in an envelope addressed to: Commissioner for Patents, Washington, D.Q. 20231.

Signature

ASSOCIATE POWER OF ATTORNEY (37 CFR 1.34)

The Assignee requests that the Patent and Trademark Office recognize as Associate Practitioners in this case:

> B. Todd Patterson, Registration No. 37,906, William B. Patterson, Registration No. 34,102, Keith M. Tackett, Registration No. 32,008, and Raymond R. Moser, Jr., Registration No. 34,682, at MOSER, PATTERSON & SHERIDAN, L.L.P. 3040 Post Oak Blvd., Suite 1500

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These Associate Practitioners are authorized to transact all business in the Patent and Trademark Office connected with this application and to receive the Letters Patent.

The Assignee hereby revokes any previous power of attorney to Irwin Ostroff, and the law firm of Ostroff & Associates.

Respectfully submitted,

APPLIED MATERIALS, INC.

Date: _*ド*) パタ/ 02

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